Status report on segmented mesh microbulk

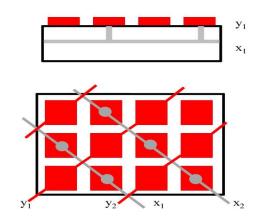
RD51 Common fund project

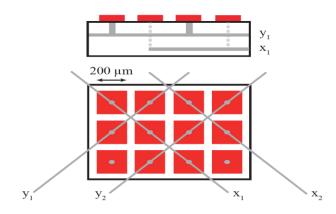
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¹University of Zaragoza, ²IRFU/CEA, ³CERN, ⁴NCSR Demokritos,

Motivations

- Develop a 2D low mass intrinsic X-Y detector
- Strategy used up to now (CAST, MIMAC, NTOF...)

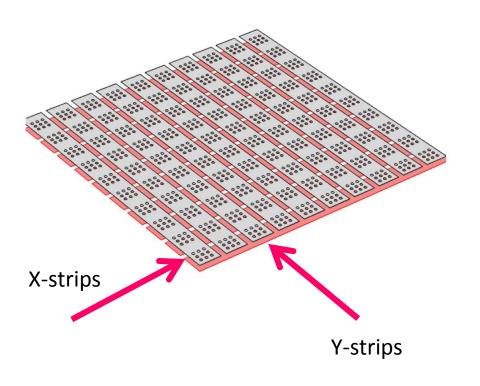




Disadvantages:

- In the limit of no diffussion, the 2D capabilities are lost
- Charge collection in X-Y is not completely equivalent
- Complexity in the manufacturing of a multilayer stack microbulk

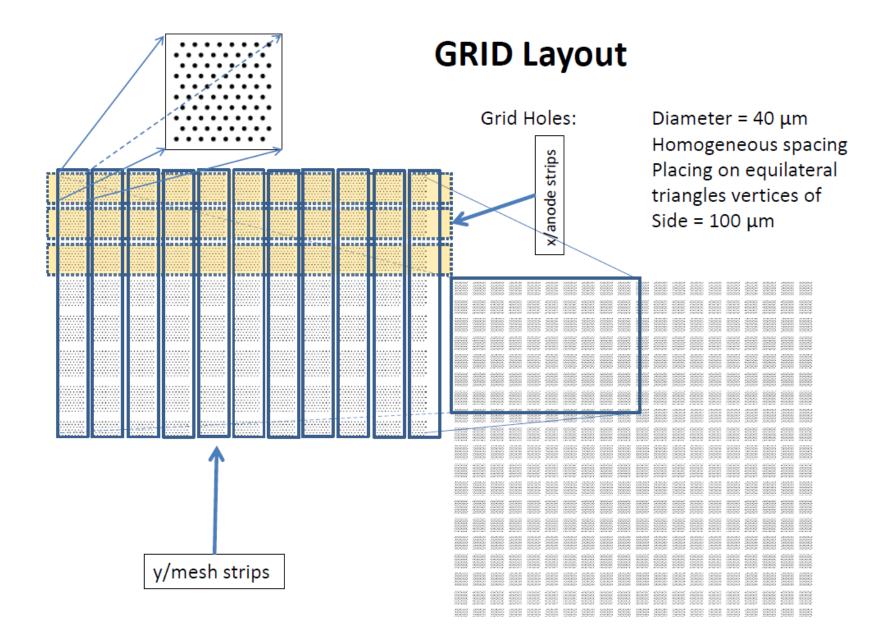
Intrinsic true 2D Microbulks



- Signal X-Y completely correlated
- Minimisation of the mass budget
- Coupled to autotrigger electronics →
 Very low threshold

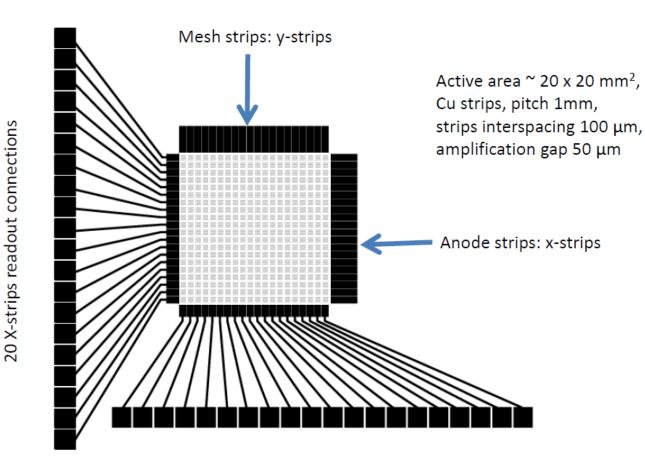
Interest: rare event detection experiments, neutron beam imagers...

Segmented mesh microbulk



Present design

X-Y strips layout and readout connections



20 Y-strips readout connections

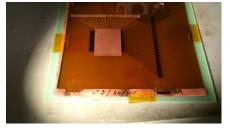
Evolution



1st batch: February 2012

Active area ~ 38 x 38 mm2, Cu strips, pitch 1mm, strips interspacing 100 μm, amplification gap 50 μm → could not hold HV, only a few strips were operational

2nd batch: November 2012





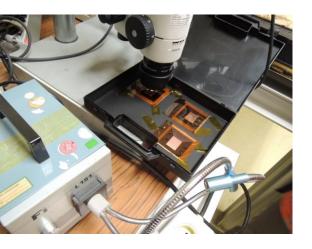
New production technique, 4 Micromegas prototypes Hold HV, No spectrum from an 55Fe source, pitch 1mm, strips interspacing 100 μm, amplification gap 50 μm

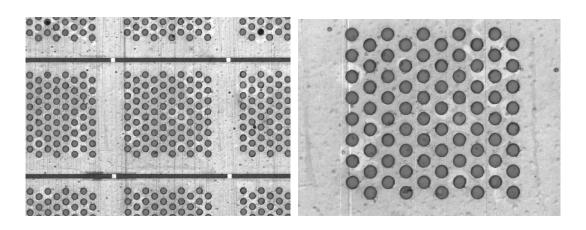
3rd batch: September 2013

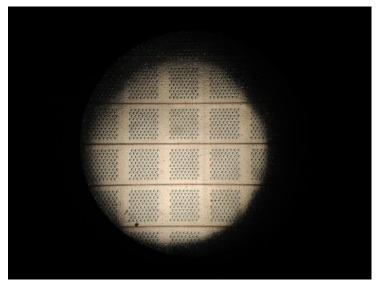
5 Detectors manufactured with different holes diameters: 2 with 45 μm and 3 with 60 μm . Pitch is 1 mm and strip interspacing reduced to 40 μm

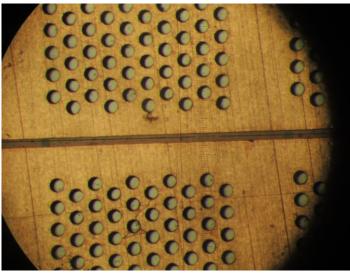
Manufacturing: first the x-strips then the mesh holes and finally the y strips. No holes on top of the x-strips gaps.

3rd Batch



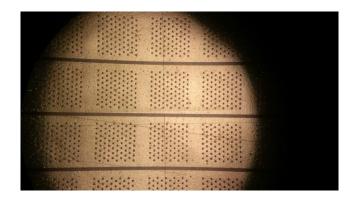


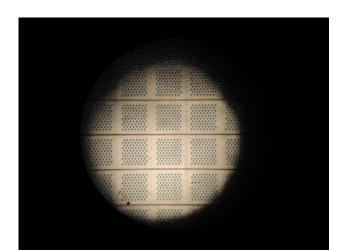




Evolution

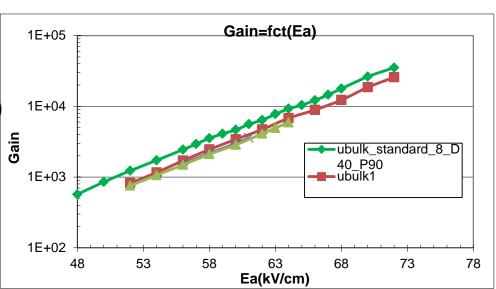


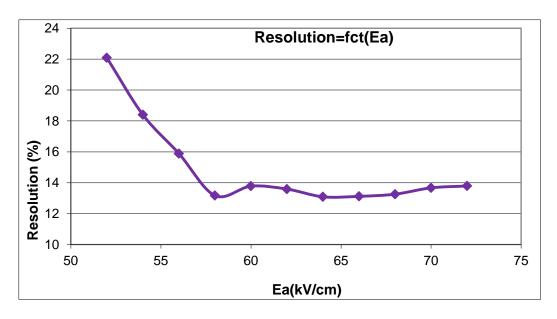




First characterisations (3rd batch)

Ar + 5% Isobutane Reading the mesh (PA Ortec+ Shaper+MCA) ⁵⁵Fe source

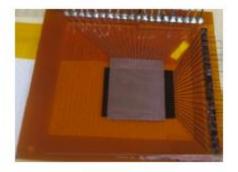




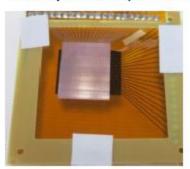
Detector Mounting for reading out the strips

Raw detector

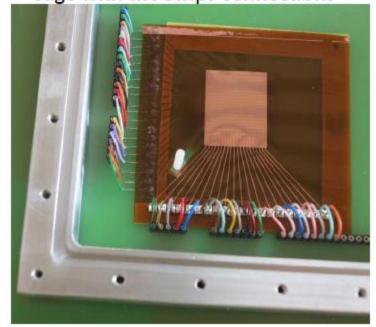
Y-strips side (Mesh)



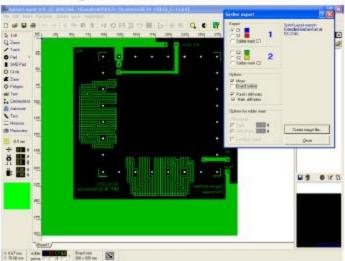
X-strips side (anode)



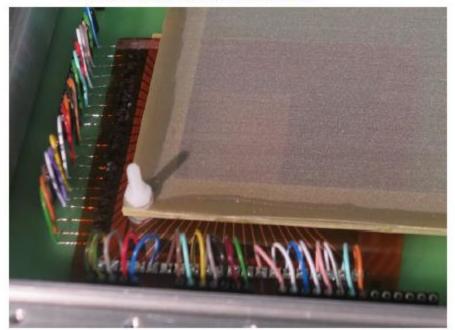
Segmented Microbulk placed in the Cage with the strips connections



PCB design to host the Microbulk



The drift electrode at 5mm



The mesh y-strips FE electronics

The mesh y-strips FE electronics

y-strips need to be supplied by the bias HV and be readout at the same time to provide the y information. A special Front End readout card was designed.

The circuit has the following characteristics:

- Readout up to 64 strips,
- HV supply for every strip independently,
- Selection of HV supplied strips individually,
- 4) Transient voltage suppression (TVS) protection and

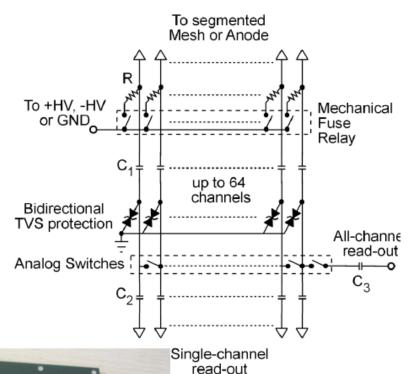
5) Single-channel read-out and all-channel

read-out.

HV or GND
BNC connector

64-pin connector
to detector

Design, build by Francisco Aznar Zaragoza



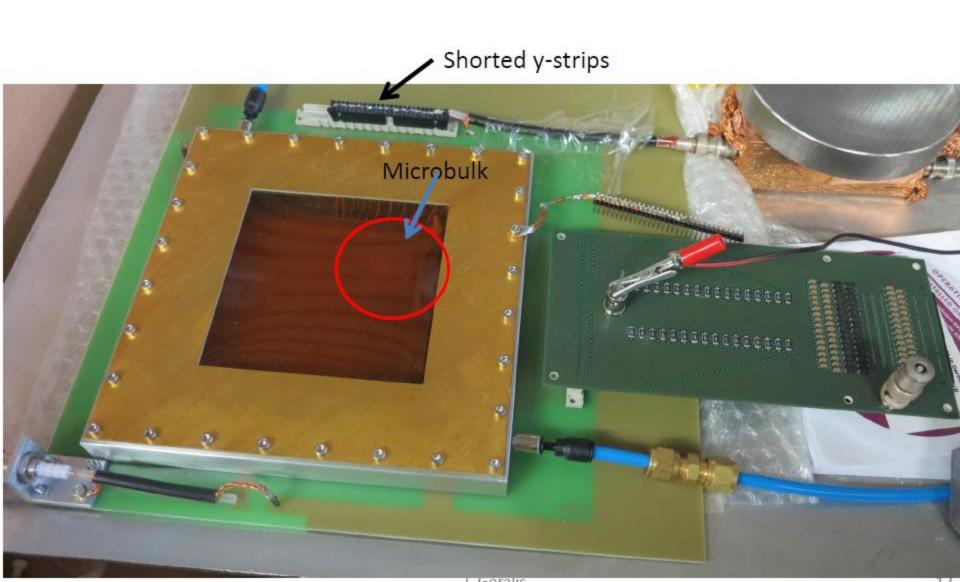
 All strips readout signal

> Jumpers to isolate Individual Strips

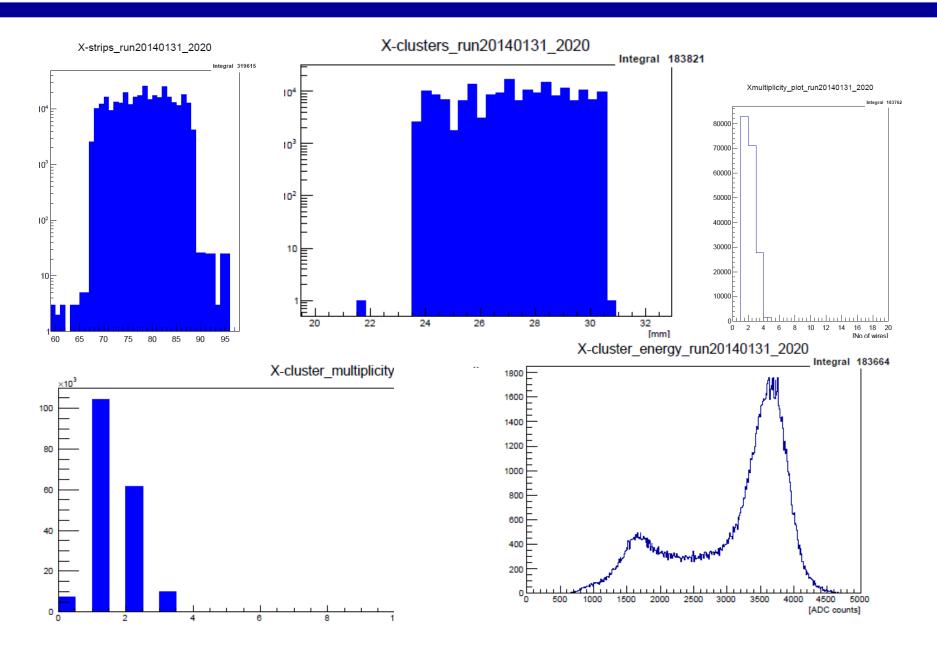
80-pin ERNI connector To Readout (AGET)

15

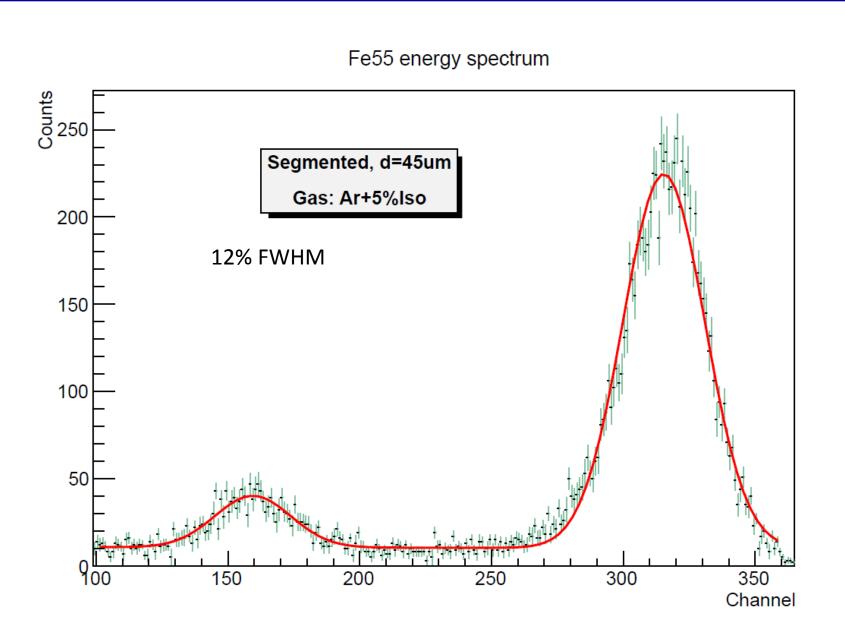
Segmented Microbulk mounted HV Front-end Readout card connected



Testing the x-strips with Gassiplex electronics



Testing the x-strips with Gassiplex electronics



Conclusions and perspectives

- •First operational segmented microbulks have been produced: they behave as standard microbulks (high gains, Eres=12% reached)
- Differences of behaviour (Eres) between 40 and 60 μ m holes: in the 60 μ m there was an alignment problem during manufaturing.
- •HV front end card has been validated
- Characterisation on going

Next steps:

- •Read Y signals with Gassiplex electronics
- •Test with autotrigger electronics: VMM1/AGET
- Optimise design
- •Built a large detector with connector: NTOF neutron beam profiler

BACK UP

New Microbulk strip method

Serge FERRY-TE/MPE/EM 28/09/2012

- 1 Base material 50 μm polyimide foil copperclad

 2 Photoresist liquid spinning, masking, exposure, development in clean room

 3 Chemical etching of copper grid of holes

 4 Polyimide etching by sprayer Fig:microbulkstrip grille.pdf

 5 Photoresit lamination on top and bot for making strip,X and Y, masking,exposure, development

 6 Chemical etching of copper top and bot + chemical etching of chromium
- 7 Cleaning + passivation, electrical test at 600v

Improvements:

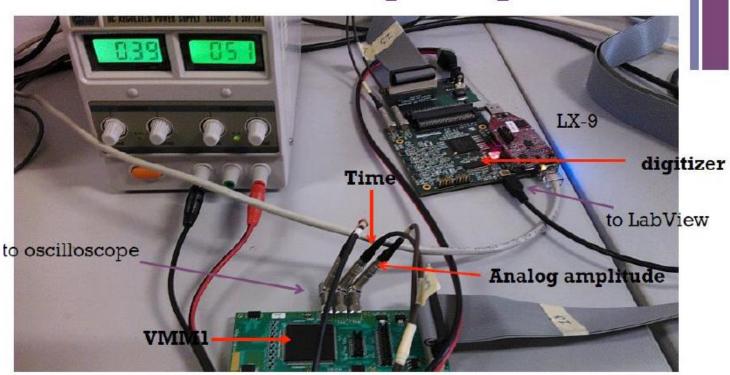
2nd Batch: Develop first the mesh holes and then the x and y strips

No holes above the anode strips gaps

1st Batch: Reverse development order, holes everywhere in the mesh strips

Waiting for the AGET electronics, we plan to use the VMM1 readout

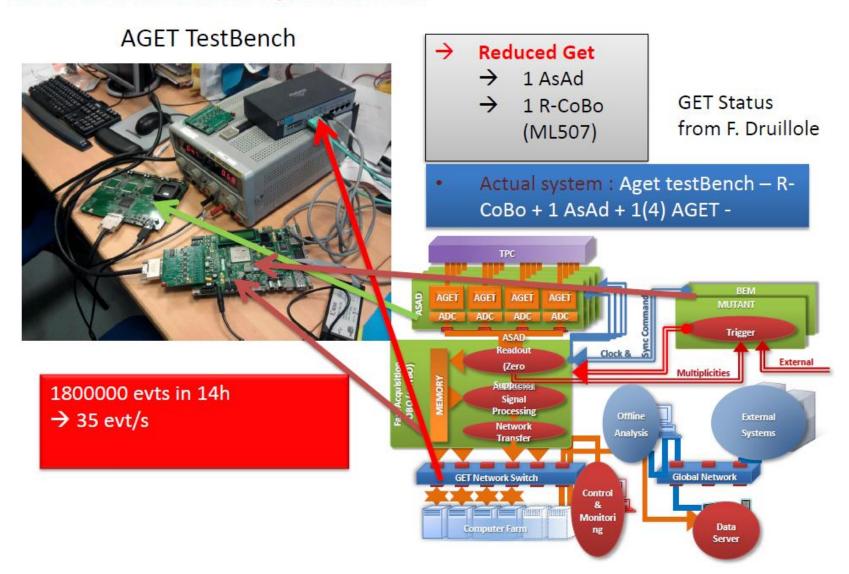
VMM1 read-out chip setup



We currently work to adapt the VMM1 electronics to readout the Segmented microbulk We possess one card with the capacity to readout 64 channels

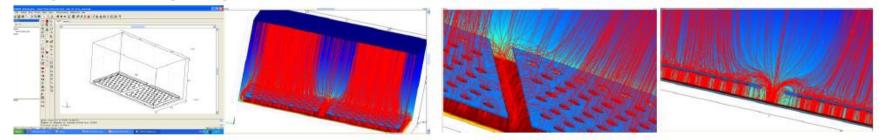
VMM1 (ATLAS ASIC for MAMMA): Auto trigger, amplitude and timing information, neighbor channel logic.

We were planning to use the AGET Readout, but it is not yet available



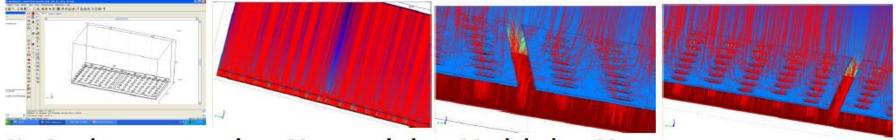
Layout Optimization using Comsol

Gap between y-strips: 100 um, Mesh holes: 50 um



Gap between y-strips: 40 um, Mesh holes: 60 um

Electric Field



No Gap between y-strips: 40 um resistive, Mesh holes: 60 um

